



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

D. KOMADA

Group Art Unit: 1765

Serial No.: 10/040,378

Examiner: Lan Vinh

Filed: January 9, 2002

Atty. Dck. No. 107317-00040

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TC 1700

For: MANUFACTURE METHOD FOR SEMICONDUCTOR DEVICE HAVING
SILICON-CONTAINING INSULATING FILM

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 2, 2003

Sir:

In reply to the outstanding Office Action dated May 7, 2003, the period for response having been extended one month from August 7, 2003 to September 7, 2003, with the filing of the attached Petition for Extension of Time, please amend the application as shown on the following pages: